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Application/Control No.	Applicant(s)/Patent under Reexamination
10/522,220	LEELARATNE ET AL.
Examiner	Art Unit
Michael C. Wimer	2828

SEARCHED			
Class	Subclass	Date	Examiner
343	711,713	5/22/2006	MCW
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
			
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